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AD-A220 566

Electronic Structure and Lubrication Properties of MoS₂: A Qualitative Molecular Orbital Approach

PAUL D. FLEISCHAUER, J. R. LINCE, P. A. BERTRAND,
and R. BAUER
Chemistry and Physics Laboratory
Laboratory Operations
The Aerospace Corporation
El Segundo, CA 90245

21 March 1990

Prepared for
SPACE SYSTEMS DIVISION
AIR FORCE SYSTEMS COMMAND
Los Angeles Air Force Base
P. O. Box 92960
Los Angeles, CA 90009-2960

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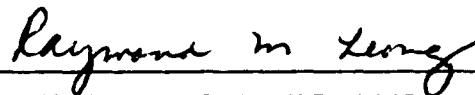
This report was submitted by The Aerospace Corporation, El Segundo, CA 90245, under Contract No. F04701-85-C-0086-P00019 with the Space Systems Division, P.O. Box 92960, Los Angeles, CA 90009-2960. It was reviewed and approved for The Aerospace Corporation by J. M. Straus, Director, Chemistry and Physics Laboratory. Lt Carl Maes was the project officer for the Mission-Oriented Investigation and Experimentation (MOIE) Program.

This report has been reviewed by the Public Affairs Office (PAS) and is releasable to the National Technical Information Service (NTIS). At NTIS, it will be available to the general public, including foreign nationals.

This technical report has been reviewed and is approved for publication. Publication of this report does not constitute Air Force approval of the report's findings or conclusions. It is published only for the exchange and stimulation of ideas.



CARL MAES, LT, USAF
MOIE Project Officer
SSD/CWDE



RAYMOND M. LEONG, MAJ, USAF
MOIE Program Manager
STC/WCO OL-AB

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SECURITY CLASSIFICATION OF THIS PAGE

REPORT DOCUMENTATION PAGE

1a. REPORT SECURITY CLASSIFICATION Unclassified			1b. RESTRICTIVE MARKINGS		
2a. SECURITY CLASSIFICATION AUTHORITY			3. DISTRIBUTION/AVAILABILITY OF REPORT		
2b. DECLASSIFICATION/DOWNGRADING SCHEDULE			Approved for public release; distribution unlimited		
4. PERFORMING ORGANIZATION REPORT NUMBER(S) TR-0088(3945-03)-1			5. MONITORING ORGANIZATION REPORT NUMBER(S) SSD-TR-90-09		
6a. NAME OF PERFORMING ORGANIZATION Laboratory Operations The Aerospace Corporation		6b. OFFICE SYMBOL (If applicable)	7a. NAME OF MONITORING ORGANIZATION Space Systems Division		
6c. ADDRESS (City, State, and ZIP Code) El Segundo, CA 90245			7b. ADDRESS (City, State, and ZIP Code) Los Angeles Air Force Base Los Angeles, CA 90009-2960		
8a. NAME OF FUNDING/SPONSORING ORGANIZATION		8b. OFFICE SYMBOL (If applicable)	9. PROCUREMENT INSTRUMENT IDENTIFICATION NUMBER FO4701-85-C-0086-P00019		
8c. ADDRESS (City, State, and ZIP Code)			10. SOURCE OF FUNDING NUMBERS		
PROGRAM ELEMENT NO.		PROJECT NO.	TASK NO.	WORK UNIT ACCESSION NO.	
11. TITLE (Include Security Classification) Electronic Structure and Lubrication Properties of MoS ₂ : A Qualitative Molecular Orbital Approach					
12. PERSONAL AUTHOR(S) Fleischauer, Paul D.; Lince, Jeffrey R.; Bertrand, P. A.; and Bauer, Reinhold					
13a. TYPE OF REPORT		13b. TIME COVERED FROM _____ TO _____		14. DATE OF REPORT (Year, Month, Day) 1990 March 21	
15. PAGE COUNT 35					
16. SUPPLEMENTARY NOTATION-					
17. COSATI CODES			18. SUBJECT TERMS (Continue on reverse if necessary and identify by block number)		
FIELD	GROUP	SUB-GROUP	Solid lubricants		
			MoS ₂ (molybdenum disulfide)		
			Electronic structure.		
19. ABSTRACT (Continue on reverse if necessary and identify by block number)					
The electronic structure of the solid lubricant material MoS₂ is described by a qualitative molecular orbital (MO) model that is based on the D_{3h} symmetry of the Mo(S)₆ unit in the crystal. The MO model is used to assign peaks in the valence-level photoelectron spectrum (VLPS) and the electron energy loss spectrum of MoS₂(0001) and to interpret the effects of ion bombardment (IB) of this surface on its electronic structure. The dependence of VLPS peak intensities on excitation energy is used to assign the energy levels in the MO diagram. Variations in crystal lattice spacing within sputter-deposited MoS₂ films are explained in terms of electron density arguments. Structural information, together with information on surface bonding and on adhesion from the IB studies, aids in predicting the lubrication performance of these films. It is proposed that the highest occupied orbital for MoS₂ is an A₁ nonbonding orbital and that important film properties, such as adhesion to substrates and friction within the film, can be manipulated by altering the electron occupancy of this orbital.					
20. DISTRIBUTION/AVAILABILITY OF ABSTRACT			21. ABSTRACT SECURITY CLASSIFICATION		
☒ UNCLASSIFIED/UNLIMITED ☐ SAME AS RPT. ☐ DTIC USERS			Unclassified		
22a. NAME OF RESPONSIBLE INDIVIDUAL			22b. TELEPHONE (Include Area Code)		22c. OFFICE SYMBOL

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SECURITY CLASSIFICATION OF THIS PAGE

18. SUBJECT TERMS, Continued

Molecular orbital theory

Lubrication

Energy levels, electronic

Photoelectron spectra of MoS₂

Ion bombardment of MoS₂

Lattice spacing of MoS₂

SECURITY CLASSIFICATION OF THIS PAGE

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PREFACE

Support for this work was provided by the Defense Advanced Research Projects Agency and the U.S. Air Force Space Systems Division Contract No. F04701-85-C-0086-P00019. This report is dedicated to the memory of Dr. C. C. Badcock.



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CONTENTS

PREFACE.....	1
I. INTRODUCTION.....	7
II. MOLECULAR ORBITAL MODEL.....	9
III. EXPERIMENTAL.....	15
IV. RESULTS AND DISCUSSION.....	17
A. VALENCE-LEVEL SPECTROSCOPY.....	17
B. ION BOMBARDMENT.....	22
C. CRYSTAL STRUCTURE.....	27
V. SUMMARY AND CONCLUSIONS.....	33
REFERENCES.....	35

FIGURES

1.	Crystal structure of 2H-MoS ₂ , showing primary crystallographic directions and dimensions.....	10
2.	Molecular orbital energy-level diagram for Mo(S) ₆ in 2H-MoS ₂	12
3.	Correlation of EELS and VLPS spectra of MoS ₂ (0001) with MO levels.....	18
4.	Variation in VLPS peaks with excitation photon energy.....	21
5.	Core-level peaks for MoS ₂ (0001), showing Mo and S peaks before and after bombardment with 5×10^{15} Ne ions cm ⁻²	23
6.	VLPS peaks for MoS ₂ (0001), showing the effects of IB with 1-keV Ne ⁺ , 225-eV excitation and 0.5-keV N ⁺ , 22.4-eV excitation.....	24
7.	EELS peaks for MoS ₂ (0001), showing the effects of IB with 1-keV Ar ⁺	25
8.	XRD scans of the (100) peak for sputter-deposited MoS ₂ films.....	28

TABLES

1.	Orbital Scheme for MoS ₂ Crystal.....	11
2.	Peak Energies and Assignments for MoS ₂ Crystals.....	19

I. INTRODUCTION

The electronic structures of layered transition metal dichalcogenide (LTMD) compounds (e.g., of MoS_2) are of great fundamental interest, primarily because of the compounds' unusual crystal structures. LTMDs are formed by stacking "sandwiches" consisting of a layer of transition-metal atoms between two layers of chalcogen atoms. There is strong covalent bonding within the sandwiches but weak, primarily van der Waals, bonding between them. This crystalline anisotropy results in anisotropy in properties such as electronic conductivity and in such diverse applications of LTMDs as catalysts, batteries, and lubricants. In addition, the electronic and crystal structures of these highly anisotropic materials vary, so that some LTMDs are very good lubricants (MoS_2) and others are poor lubricants (NbSe_2) or abrasives (TaS_2).^{1,2} Likewise, these materials can demonstrate wide variations in electronic type; LTMDs can be semiconductors (TiS_2 , MoS_2), semimetals (TiSe_2 , WTe_2), or superconductors (TaS_2 , NbSe_2).³

Numerous experimental and theoretical investigations of LTMDs have attempted to describe their electronic structures³⁻¹³ and to correlate those structures with catalytic activity^{3,12,13} and lubrication performance.^{14,15} Photoelectron spectroscopic, electron energy loss spectroscopic, and x-ray absorption/emission measurements have been compared with various theoretical [semiempirical band structure and molecular orbital (MO)] treatments of the electronic energy levels in order to describe the valence electronic structures of the layered compounds, especially those of MoS_2 . But many of those studies encountered difficulties in fitting theory to experiment, primarily because no attempt was made to incorporate the effects of intralayer covalent bonding between molybdenum and sulfur into the band structure calculations. In a recent study of MoSe_2 , MoS_2 , and WS_2 , the augmented-spherical-wave (ASW) method of calculating band structures, including metal-chalcogen covalency, was used to generate valence- and conduction-band states that agreed well with the results of angle-resolved ultraviolet photoelectron spectroscopy and optical band-gap

measurements.^{12,13} Those studies involve complex calculations on model systems of pure materials. Such models can be difficult to apply to real materials, i.e., materials that have been chemically or structurally modified. The main purpose of this report is to show that a wide variety of properties of varying systems can be described by a relatively simple, qualitative MO model that is easy to apply to real systems.

In this report, data are presented on the energy dependences of cross sections and sampling depths for valence-level electronic transitions, measured by valence-level photoelectron spectroscopy (VLPS); the chemical modification of $\text{MoS}_2(0001)$ by ion bombardment, measured by electron energy loss spectroscopy (EELS), core level photoelectron spectroscopy (CLPS), and VLPS; and bulk crystal structural variations--specifically differences in the lattice spacings--of MoS_2 thin films prepared by sputter deposition and measured by x-ray diffraction. All results are interpreted with the aid of the MO model of the energy levels of the $\text{Mo}(\text{S})_6$ unit within the MoS_2 crystal. This simple model is used in conjunction with spectroscopic data to predict performance properties (adhesion, friction, and wear) of solid film lubricants and to recommend substitutions for lubricant surface and bulk constituents that would alter those properties.

II. MOLECULAR ORBITAL MODEL

Within the layered crystal of $2H-MoS_2$, shown in Fig. 1, each Mo atom is surrounded by six S atoms in the form of a trigonal prism (TP). Each S atom forms the apex of a triangular pyramid that has three Mo atoms at its base and Mo-S-Mo bond angles of approximately 82° . Using standard group theory, molecular orbitals for the $Mo(S)_6$ units can be constructed according to the irreducible representations for the D_{3h} symmetry point group (i.e., the TP structure). The entire set of wave functions and a complete MO energy-level diagram for a molecule with D_{3h} symmetry have been published.¹⁶ However, application to the MoS_2 system requires that a major difference be recognized between the bonding for a single molecule (i.e., ML_6) and that for an $Mo(S)_6$ group within a MoS_2 crystal: specifically, the degree of involvement (if any) of pi bonding orbitals.

Previous attempts at describing the electronic structure⁴ of TiS_2 and at interpreting the lubricant properties of LTMDs, including MoS_2 , with MO theory¹⁴ have been unduly complicated because they failed to recognize the repetition or periodicity of the $Mo(S)_6$ units in the crystalline materials. They invoked S 3p-pi orbitals, which do not exist in these crystals, because each sulfur bonds to three metal atoms and not one. The 82° Mo-S-Mo bond angles in MoS_2 are slightly smaller than expected for the involvement of essentially unhybridized S 3p orbitals in sigma bonding to three Mo atoms within a sandwich. However, hybridization of the sulfur orbitals (i.e., with the 3s or 3d orbitals) would have the effect of favoring Mo-S-Mo bond angles larger than 90° .

The pertinent MO wave functions (used in the above-mentioned MO model) are reproduced in Table 1, and the energy-level diagram for the crystal is simplified substantially from that of Ref. 16 or Ref. 14 as shown in Fig. 2. There are seven bonding/nonbonding MO energy levels that exactly accommodate the 14 valence electrons in the $Mo(S)_6$ unit within the crystal. (The ordering of levels in Fig. 2 is assigned on the basis of spectral data presented in "Results and Discussion," Section IV.)

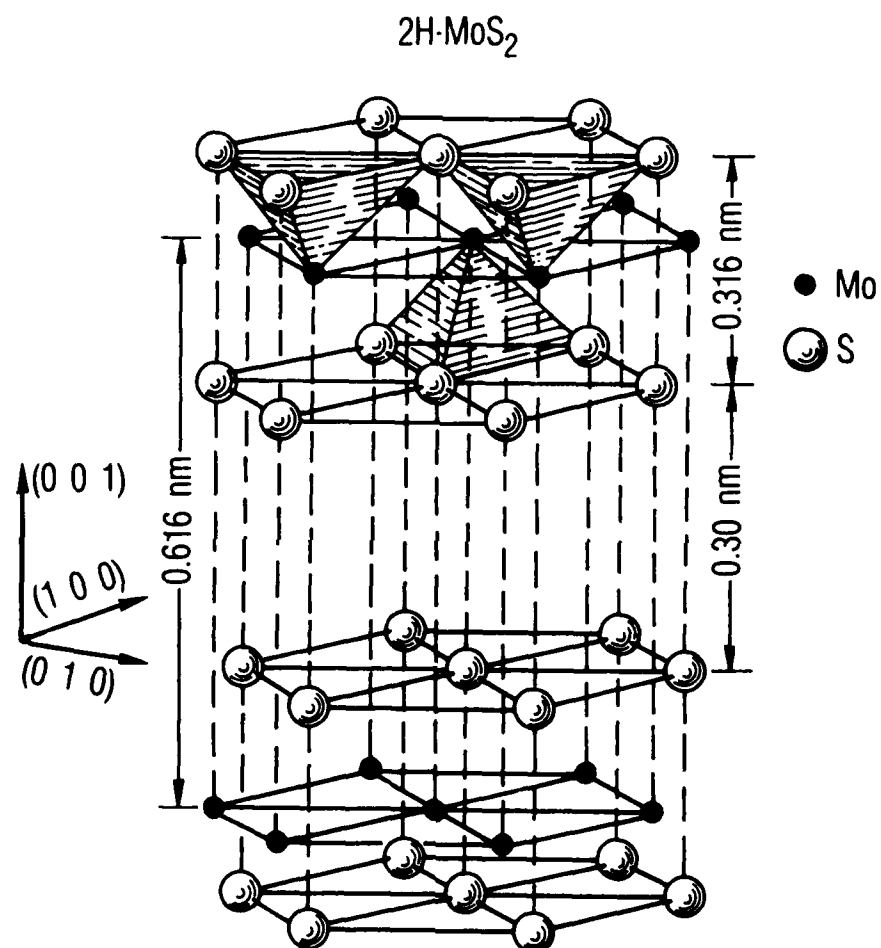


Fig. 1. Crystal structure of $2H-MoS_2$, showing primary crystallographic directions and dimensions.

TABLE 1. ORBITAL SCHEME FOR MoS₂ CRYSTAL

Irreducible representation	Mo orbitals	S orbitals
A ₁ ^a	4d _z ² , 5s	$\frac{1}{\sqrt{6}}(\sigma_1 + \sigma_2 + \sigma_3 + \sigma_4 + \sigma_5 + \sigma_6)$
A ₂ ^a	5p _z	$\frac{1}{\sqrt{6}}(\sigma_1 - \sigma_2 + \sigma_3 - \sigma_4 + \sigma_5 - \sigma_6)$
E ^a	(4d _{xz} , 4d _{yz})	$\frac{1}{2\sqrt{3}}(2\sigma_1 - \sigma_3 - \sigma_5 - 2\sigma_2 + \sigma_4 + \sigma_6)$
		$\frac{1}{2}(\sigma_3 - \sigma_4 - \sigma_5 + \sigma_6)$
E'	(4d _{xy} , 4d _{x²-y²})	$\frac{1}{2\sqrt{3}}(2\sigma_1 - \sigma_3 - \sigma_5 + 2\sigma_2 - \sigma_4 - \sigma_6)$
	(5p _x , p _y)	$\frac{1}{2}(\sigma_3 + \sigma_4 - \sigma_5 - \sigma_6)$
A ₁ '	5s, 4d _z ²	$\frac{1}{\sqrt{6}}(\sigma_1 + \sigma_2 + \sigma_3 + \sigma_4 + \sigma_5 + \sigma_6)$

^aFrom group theory, there are two A₁' irreducible representations; one is assigned primarily 5s character and is a bonding MO, and the other is assigned primarily 4d_z² and is a nonbonding MO. See text for further discussion. Orbital designation (coordinate system) after Ref. 16.

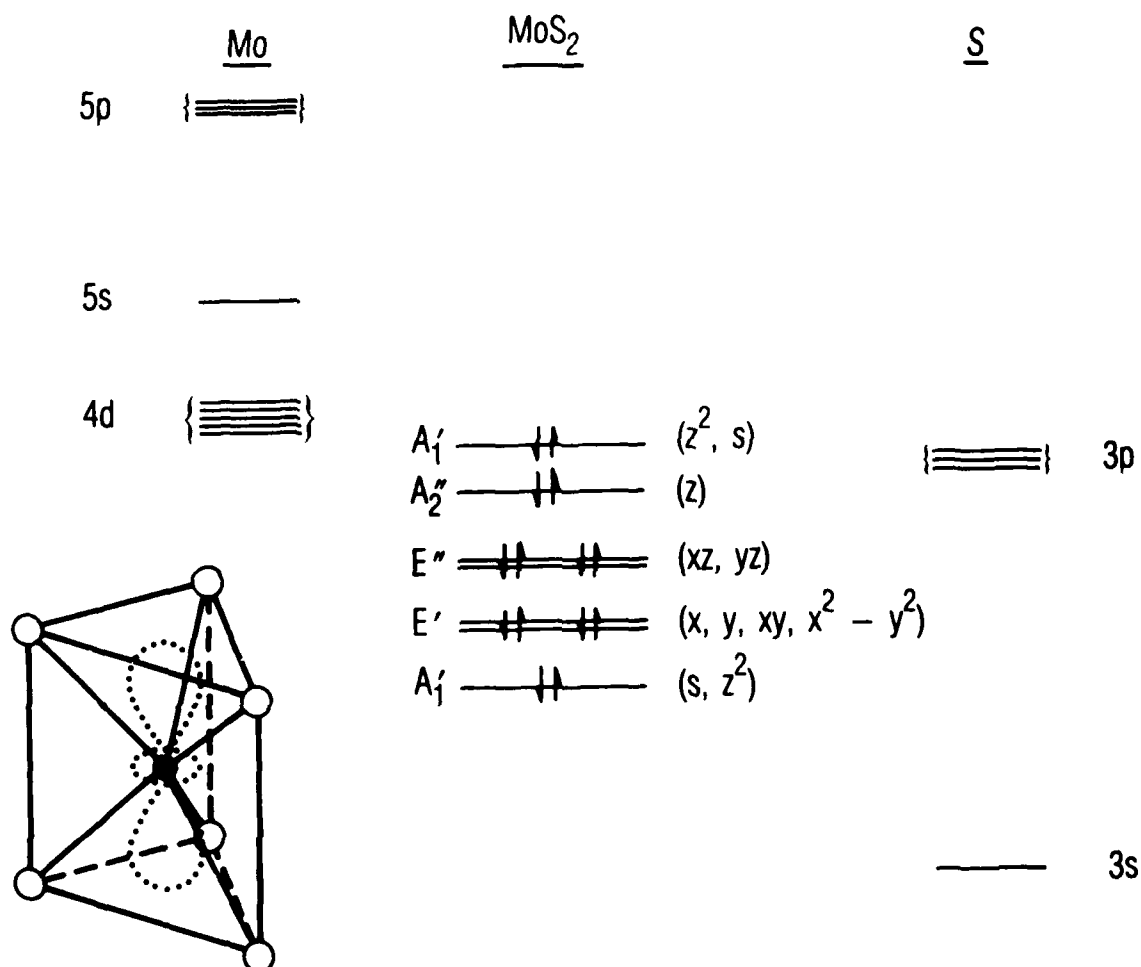


Fig. 2. Molecular orbital energy-level diagram for Mo(S)_6 in 2H-MoS_2 . The terms in parentheses (e.g., z^2 , s , xz) represent the metal orbitals that make primary contributions to the MOs.

From this MO interpretation, it is evident that for MoS_2 all of the accessible orbitals for both Mo and S are completely involved in intralayer bonding, leaving only high-energy antibonding orbitals available for interlayer bonding or interfacial bonding with other materials. There are no dangling bonds (i.e., accessible orbitals) on either the Mo or S surface atoms: The "lone pairs" of S $3s$ electrons occupy very stable orbitals, and such stability means that $3s$ electron density remains close to the S atoms and, therefore, does not interact strongly with adatoms.

These electron distributions and bonding properties have major implications for tribological performance (as well as for catalytic activities and battery operation), because subtle variations in crystal structure and adhesion properties at film-substrate interfaces govern lubricant film friction and endurance. Our attempt to prepare MoS_2 lubricant films that are oriented with their basal planes parallel to the appropriate substrate surface and that adhere strongly to that surface^{15,17-20} is a primary motivation for the studies described and discussed in the following sections. The undisturbed (0001) basal surface of MoS_2 cannot form bonds or react unless its molecular orbital structure is altered by physical or chemical manipulation (for example, by ion bombardment^{21,22}).

III. EXPERIMENTAL

MoS₂ crystals used for the VLPS and ion-bombardment studies were natural molybdenite mined near Froland, Norway, and purchased from Ward's Natural Science Establishment, Rochester, NY. For the photoelectron spectroscopic measurements, they were first prepared by being cleaved in air, mounted in the ultrahigh vacuum (UHV) system immediately and evacuating the system, and then heated to ~500°C, usually for ~10 min, until no evidence of carbon or oxygen could be obtained with CLPS [i.e., ~0.05 monolayer (ML)]. After this treatment a 1 × 1 low-energy electron diffraction (LEED) pattern was obtained. For EELS, the crystals were cleaved under N₂ or argon and mounted in the UHV system without heating. Auger spectroscopy revealed no oxygen but some carbon (~0.2 ML) on the basal surface after evacuating to ~3 × 10⁻⁹ torr.

Thin films of MoS₂ were prepared by rf sputter deposition according to procedures described in previous publications.^{17-19,23} Briefly, the deposition system consists of a 152-mm (6-in.)-diameter target made by hot-pressing MoS₂ powder (99.9% pure). The substrates were 440C stainless steel that were polished with 300-nm Al₂O₃ powder in a slurry and degreased with acetone and methanol immediately before being inserted into the sputtering chamber and subsequent pumpdown. The base pressure of the vacuum system was ~1 × 10⁻⁶ torr. The target-to-substrate distance was 36 mm; argon sputtering-gas pressure was ~2 × 10⁻² torr; and power density was 1.93 × 10⁴ W m⁻², resulting in typical sputtering rates of 35-45 nm min⁻¹. The substrates were electrically grounded and had a bias voltage of 0 V.

The degree of cleanliness, specifically, the presence of water impurities in the sputtering chamber and in the target, has a large effect on the purity of the resultant films.²⁴⁻²⁶ For this reason, the target was pre-sputtered onto a shutter over the samples for 2 h prior to film deposition in order to outgas the target and to permit the sputtering rate and stoichiometry to attain a steady state. However, the presence of water on the chamber walls can oxidize the films during deposition. We used this fact to obtain MoS₂ films with variable amounts of MoO₃ throughout their bulk.

Films were also deposited onto substrates maintained at different temperatures. The substrate temperature was permitted to float during presputtering and deposition; the substrates reached a temperature of -70°C . Immediately after sputtering, the chamber was vented with Ar and the samples were placed in desiccators over anhydrous CaSO_4 until x-ray diffraction (XRD) analysis could be performed. Some samples were stored in a chamber that contained a saturated aqueous solution of KBr to maintain a relative humidity of $\sim 85\%$. Some film samples were annealed either in a vacuum chamber with a base pressure of $\sim 5 \times 10^{-8}$ torr or in a pure or sulfur-doped Ar stream, for reasons described later in the report.

EELS spectra were measured with a Perkin-Elmer PHI model 590 scanning Auger microprobe (SAM) equipped with a Varian model 981-2145 electron gun operated at 200 eV as the primary source. The spectra are recorded as the negative of the second derivative of the signal as a function of the analyzer pass energy. Loss spectra are displayed as shifts from the elastic peak at 200 eV. The energy resolution of the EELS system was approximately 1 eV. The $\text{MoS}_2(0001)$ surface was ion-bombarded by backfilling the vacuum chamber with argon or neon to a pressure of 1×10^{-5} torr and using the ion gun of the SAM operated at 1 keV. Photoelectron spectroscopy (PS) measurements were taken at beam line U8-B of the National Synchrotron Light Source at Brookhaven National Laboratory. The energy of the excitation source was selected with a toroidal grating monochromator, and the emitted electrons were detected and analyzed with a high-resolution ellipsoidal mirror analyzer. The overall energy resolution of this system was ~ 0.3 eV. All spectra were normalized with respect to the incident photon intensity. Ion bombardment was done in this system by backfilling the chamber with 5×10^{-5} torr of Ar or Ne and sputtering with 1-keV ions.

XRD analysis was done with a Phillips Electronics APD-3720 vertical powder diffractometer equipped for normal θ - 2θ scans using Cu-K α x rays ($1.54\text{-}\text{\AA}$ wavelength) according to procedures described in Ref. 18. The relative levels of oxidation of the thin films were determined by XPS with a McPherson model ESCA-36 equipped with a position-sensitive detection system.^{17,27}

IV. RESULTS AND DISCUSSION

A. VALENCE-LEVEL SPECTROSCOPY

Angle-integrated VLPS spectra give an indication of the density of states of the valence band averaged throughout the Brillouin zone. Typical electron energy loss and valence-level photoelectron spectra are displayed in Fig. 3. Peak energies are given in Table 2. Five peaks are observed in the energy range from 0 to ~8 eV below the elastic-peak position (EELS) and the Fermi level (VLPS) (although not all five are fully resolved in the EELS). They are assigned to the appropriate MO energy levels according to the scheme in Fig. 2. The S 3s peak at 11-12 eV is isolated from these five peaks, in agreement with the postulate that there is probably no hybridization of S p and s orbitals and therefore no pi orbitals in the crystal.

It is important to understand that an EELS spectrum involves atomic or molecular orbitals as both initial and final states, whereas in photoelectron spectroscopy the final state is a free electron. Generally, an atomic initial state (which is narrow and well isolated in energy from the valence band) can be used to map out the unoccupied states in the conduction band in an EELS experiment. Here, we use the conduction-band density of states determined previously¹⁰ using the S(2p) core electrons in MoS₂. The second peak at 5.3 eV from the elastic peak involves excitation from one valence level, E", to the lowest empty conduction level (CB I) and from a higher valence level, A₁', to a higher conduction level (CB II).¹⁰ Also, the excitation cross sections are different between EELS and VLPS; therefore, changes in the EELS peaks with IB or substitution will not be quantitatively the same as for the VLPS peaks. However, because the density of states in the conduction band is greater near the Fermi level than it is at higher energies,^{10,12} the EELS spectra may be thought of as being qualitatively comparable to the VLPS spectra after appropriate alignment of the energy scales, as in Fig. 3.

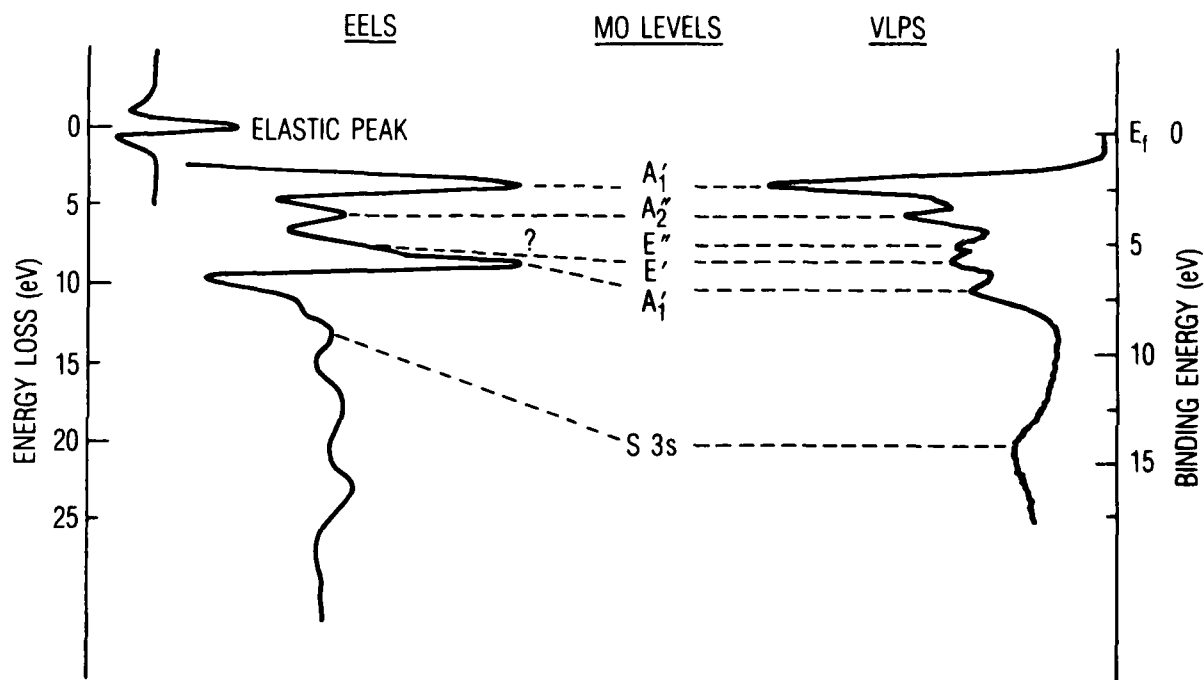


Fig. 3. Correlation of EELS and VLPS spectra of MoS₂(0001) with MO levels. Lines for EELS peaks represent transitions from indicated valence level to CB 1, see Table 2.

TABLE 2. PEAK ENERGIES AND ASSIGNMENTS FOR MoS₂ CRYSTALS

VLPS ^a			EELS ^b	
1.	A ₁ '	2.5 eV	A ₁ ' → CB I	3.5 eV
2.	A ₂ "	3.8 eV	A ₁ ' → CB II	5.3 eV
3.	E"	5.1 eV	A ₂ " → CB I	
4.	E'	5.8 eV	E" ? → CB II	7.5 eV
5.	A ₁ '	7.1 eV	E' ? → CB I	
			A' → CB I	8.5 eV
			E' → CB II	

^aPeak numbers refer to Fig. 4; term symbols are for levels from which valence electron is excited.

^bTransitions refer to electron excitation from valence level to either of two conduction-band levels. See text and Ref. 10.

The VLPS spectra in Fig. 4 illustrate the dependence of the relative intensities of such valence-level peaks on the energy of the excitation source.^{8,29} Two aspects of photon energy dependence are important for studies of surface chemistry and structure: (1) the variations in cross sections for different peaks, and (2) the variations in effective sampling depth as a function of excitation energy. Cross-section variations with photon (excitation) energy differ according to which orbitals of MoS₂ are contributing to the initial state that corresponds to the observed peak. For example, peaks derived primarily from Mo 4d orbitals exhibit a phenomenon known as a Cooper minimum (CM).⁸ The CM is manifested as a minimum in the relative intensities of such peaks as the excitation energy passes through a particular range. Peaks derived from s and p orbitals can exhibit CM, but for MoS₂ the minima would be well out of the pertinent energy range. In Ref. 8, two peaks (numbered 1 and 5 in Fig. 4) were reported to exhibit intensity minima relative to the other valence peaks for excitation energies in the 100- to 110-eV range; the authors used this fact to argue that peaks 1 and 5 involve ground-state energy levels that have major contributions from Mo 4d orbitals. Because of the unsymmetrical shape of the cross-section variation about the CM, the intensities of peaks 1 and 5 for 60-eV excitation energy (Fig. 4) are substantially greater than for 225-eV photons.

These spectra also indicate that the relative intensity of peak 4 (and to a lesser extent peak 3) increases more with increasing excitation energy (up to ~100 eV) than do the other four (three) peaks. Following the logic of Ref. 8, we could say that peaks 3 and 4 involve energy levels derived primarily from S 3p orbitals--an observation that is entirely consistent with the MO model of the MoS₂ electronic structure and provides information for the assignment of the different MO energy levels (see Fig. 2).

The second aspect of photon energy dependence, variations in effective sampling depth when different excitation energies are used, results because the emitted electrons for different spectra have different kinetic energies (KEs). The lowest-energy peak for MoS₂ (peak 1 in Fig. 4) is only 2.5 eV below the Fermi level; these photoelectrons have KEs just slightly less

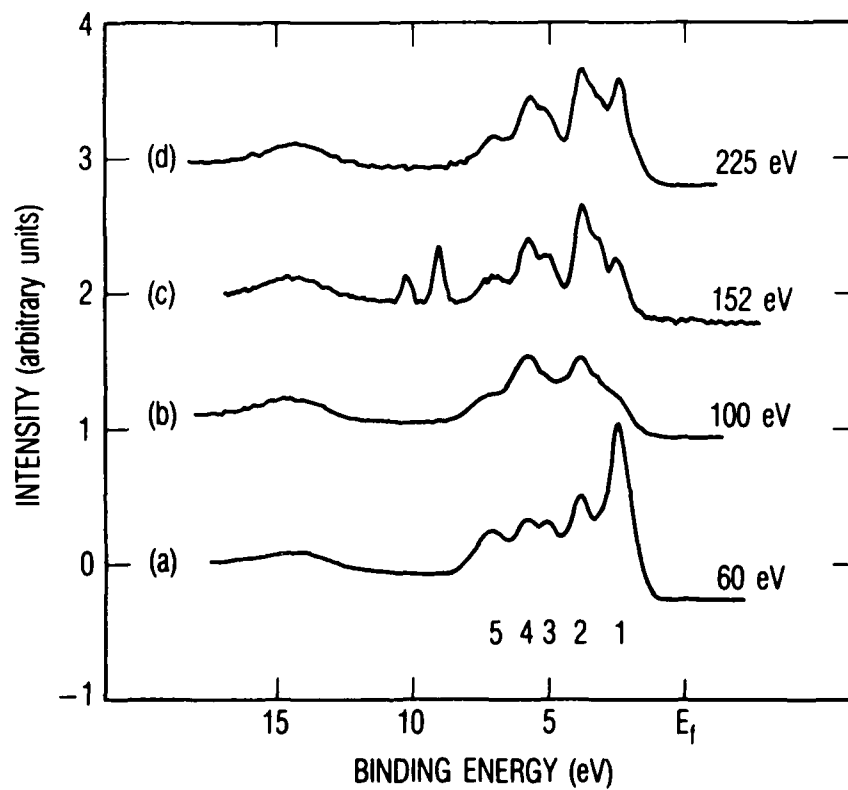


Fig. 4. Variation in VLPS peaks with excitation photon energy. (The two peaks at binding energies of approximately 7-9 eV in spectrum c are S $2s$ core-level peaks produced by second order excitation.)

than that of the excitation source. The escape depths for electrons with KEs ranging from approximately 40 to 60 eV (as in Figs. 3 and 4a) is 0.35 nm, corresponding approximately to one S-Mo-S sandwich, whereas those with 225-eV KE (as in Figs. 4b through d and 6) escape over a depth of about 0.7 nm that includes approximately two sandwiches (see Fig. 1). (For these calculations we used the formula given in Ref. 30 with the pertinent parameters for MoS_2 .)

B. ION BOMBARDMENT

The effects of ion bombardment (IB) of the $\text{MoS}_2(0001)$ surface on surface composition and relative energy-level populations are shown in Figs. 5 through 7. Changes in the core-level spectra (Fig. 5) reveal two primary chemical effects: the preferential depletion of sulfur and the formation of molybdenum metal.^{21,22} In both VLPS and EELS measurements of the valence band, the intensities of the two lowest-energy peaks are diminished relative to the other nearby peaks after the bombardment (Figs. 6 and 7). Also, the intensity of the S $3s$ peak is decreased, especially in the EELS spectra, in agreement with the reduced S:Mo ratio determined from the core-level peaks.

The effects of low levels of IB on the valence levels of MoS_2 are more obvious for low-energy excitation that probes only the first S-Mo-S sandwich (Fig. 6B). One chemical effect of the bombardment is to preferentially remove sulfur, creating sulfur vacancies, although some Mo metal and polysulfide ions are also formed.³¹ The sulfur presumably escapes with its valence electrons either as atomic or ionic sulfur. The basic TP geometry is at least partially maintained in the absence of some sulfur, since there is evidence that the S:Mo ratio in thin films can get as low as 1:1 while the 2H structure remains intact.³² Therefore, as electrons are depleted from the lower sulfur-derived MO levels, those in the upper d levels, A_1' and A_2'' , cascade down to fill the holes. The net effect is that the electron occupancy of the primarily S p derived levels, E'' and E' , remains essentially unchanged, whereas that of the uppermost levels, A_1' and A_2'' , is reduced.

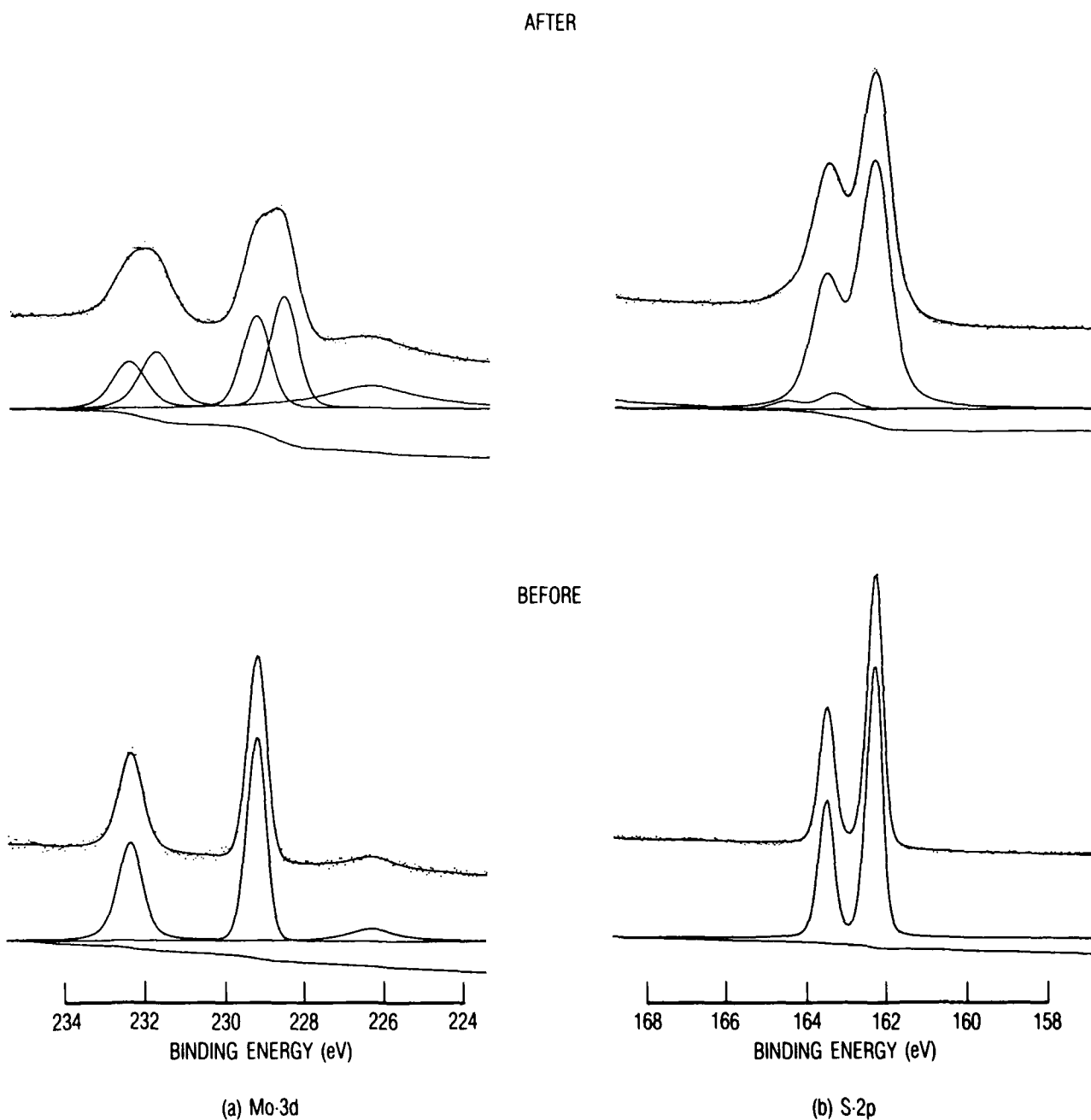


Fig. 5. Core-level peaks for $\text{MoS}_2(0001)$, showing (a) Mo and (b) S peaks before and after bombardment with 5×10^{15} Ne ions cm^{-2} . The new Mo peaks are in the direction for Mo metal, whereas those for S are probably for polysulfide. (Peak intensities cannot be compared for the Mo and S spectra because different photon energies were used and the normalization procedure could not correct for these differences.)

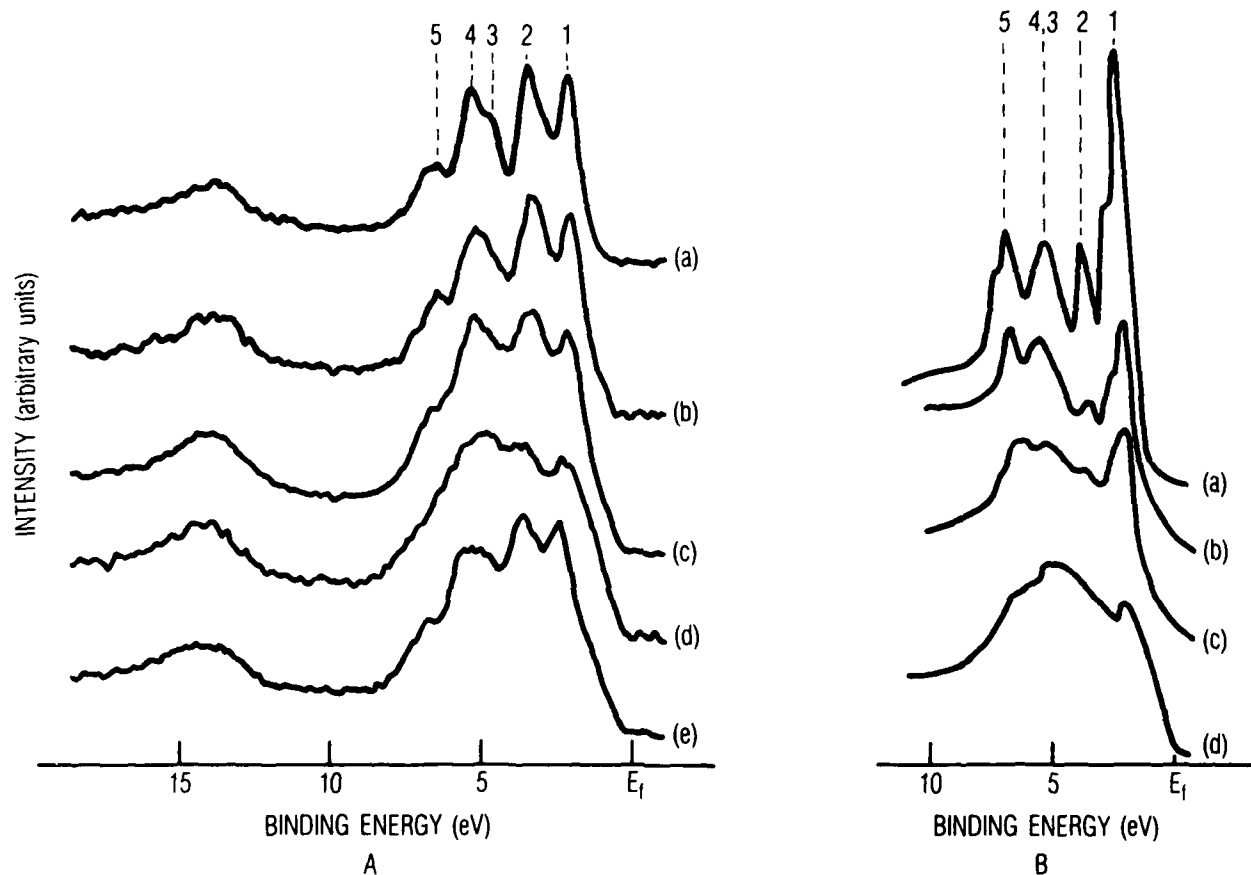


Fig. 6. VLPS peaks for $\text{MoS}_2(0001)$, showing the effects of IB with: (A) 1-keV Ne^+ , 225-eV excitation--(a) initial, (b) 2×10^{14} , (c) 1×10^{15} , (d) 5×10^{15} ions cm^{-2} , and (e) after annealing to $750 \pm 50^\circ\text{C}$; and (B) 0.5-keV N^+ , 22.4-eV excitation--(a) initial, (b) 5 s, (c) 10 s, and (d) 300 s (no flux given, Ref. 29).

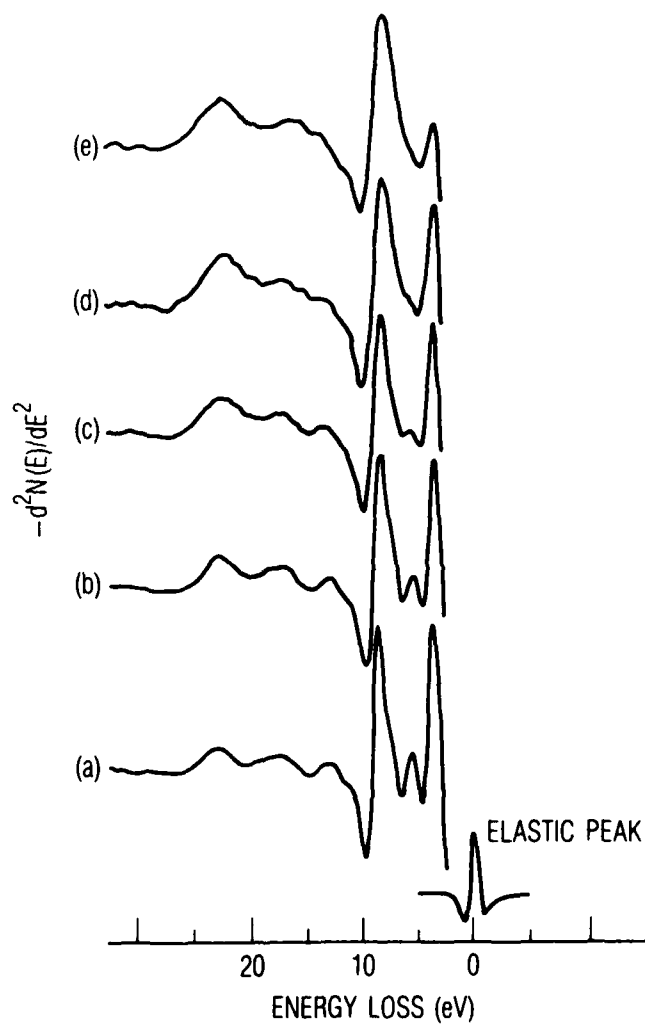


Fig. 7. EELS peaks for $\text{MoS}_2(0001)$, showing the effects of IB with 1-keV Ar^+ : (a) initial, (b) 1×10^{14} , (c) 1×10^{15} , (d) 3×10^{15} , and (e) 2×10^{16} ions cm^{-2} .

The ion-induced reduction in the relative intensities of peaks 1 and 2 is large for the lower-energy excitation (Fig. 6B), and somewhat less for the submonolayer doses of ions when two or more sandwiches are sampled with the higher-energy excitation in Fig. 6A. The effects of such low ion doses apparently are emphasized in the outermost sandwich layer; such emphasis promotes very selective surface modification for creating bonding sites.

Higher doses of ions cause broadening of the low-binding-energy side of the VLPS peaks, consistent with the formation of a higher metallic content of the surface. The metal formation can distort the spectra in two ways: It convolves the metal valence-level peaks with those of the semiconductor, and it causes metal atoms²⁰ to donate electrons into the valence levels of the MoS₂ (Schottky-barrier formation) to partially replenish the empty orbitals created by sulfur removal.

The MoS₂ valence-level peaks become well defined again after annealing of the heavily bombarded surface, and the Mo metal band edge is slightly separated (Fig. 6A). Our preliminary interpretation of these observations is that metal atoms are well dispersed within the surface region as a result of IB and that annealing causes these atoms to agglomerate into islands coexisting with highly disordered MoS₂.

The tribological consequence of modifying the MoS₂(0001) surface is that the adhesion of this surface to appropriate substrates can be improved for deposited films. Formation of sulfur vacancies and molybdenum clusters during film deposition may enhance adhesion. But other possibilities are suggested by the MO model; specifically, the incorporation of substituent atoms into the S vacancies--atoms that could hybridize to form bonds to the MoS_{2-x} surface and also to the substrate atoms (i.e., bridge bonding)--should provide interfaces with strong adhesion. The coordination geometry of the S vacancy indicates that a substituent that prefers octahedral (O_h) coordination could satisfy bonds within the MoS₂ and have orbitals available for substrate bonding. Such a substituent would need d orbitals available for d²sp³ hybridization and fewer electrons in its configuration (than that for S of MoS₂) to accommodate electron donation from metallic

substrates. Candidates for effective substituents include elements to the left of and at least one row below sulfur in the periodic table. Possible evidence for beneficial substituent effects is provided by empirical studies in which rhodium or nickel (both disposed toward O_h coordination) was predeposited³³ or codeposited,³⁴ respectively, and was found to improve the friction and wear performance of sputtered films.

C. CRYSTAL STRUCTURE

Polycrystalline, sputter-deposited films of MoS_2 are used extensively for lubrication in vacuum environments, such as those for aerospace applications.^{17,26,34-37} Properties of the crystallites that compose the films--lattice spacing, aspect ratio (of the edge surface to basal surface areas), orientation, and size--determine the films' lubrication performance; that is, their friction, wear, and reactivity toward oxidizing environments.¹⁵

These crystal structural properties can be determined by x-ray diffraction measurements, together with surface analysis techniques and electron microscopy, even for thin films (200 to 1000 nm). Typical XRD data for MoS_2 films on stainless-steel substrates are shown in Fig. 8. These scans, expanded around specific reflections, were obtained by counting the x-ray signals for long periods with the diffractometer set in the region of a specific reflection. Full θ - 2θ scans of as-prepared films manifest only two significant reflections--those for the (100) and the (110) planes; there is no evidence for (001) reflections.¹⁸ The geometry of the analysis is such that only reflections from planes parallel to the substrate surface will be detected. Therefore, these films were deposited with the basal crystal surfaces perpendicular to the plane of the substrate surface, the exact opposite of the desired configuration for low shear and good lubrication. The films probably grow with this crystal orientation because of the strong chemical bonding between the active sites on the edge [(110) or (100)] planes and those on the substrate (e.g., adsorbed H_2O or OH^-).

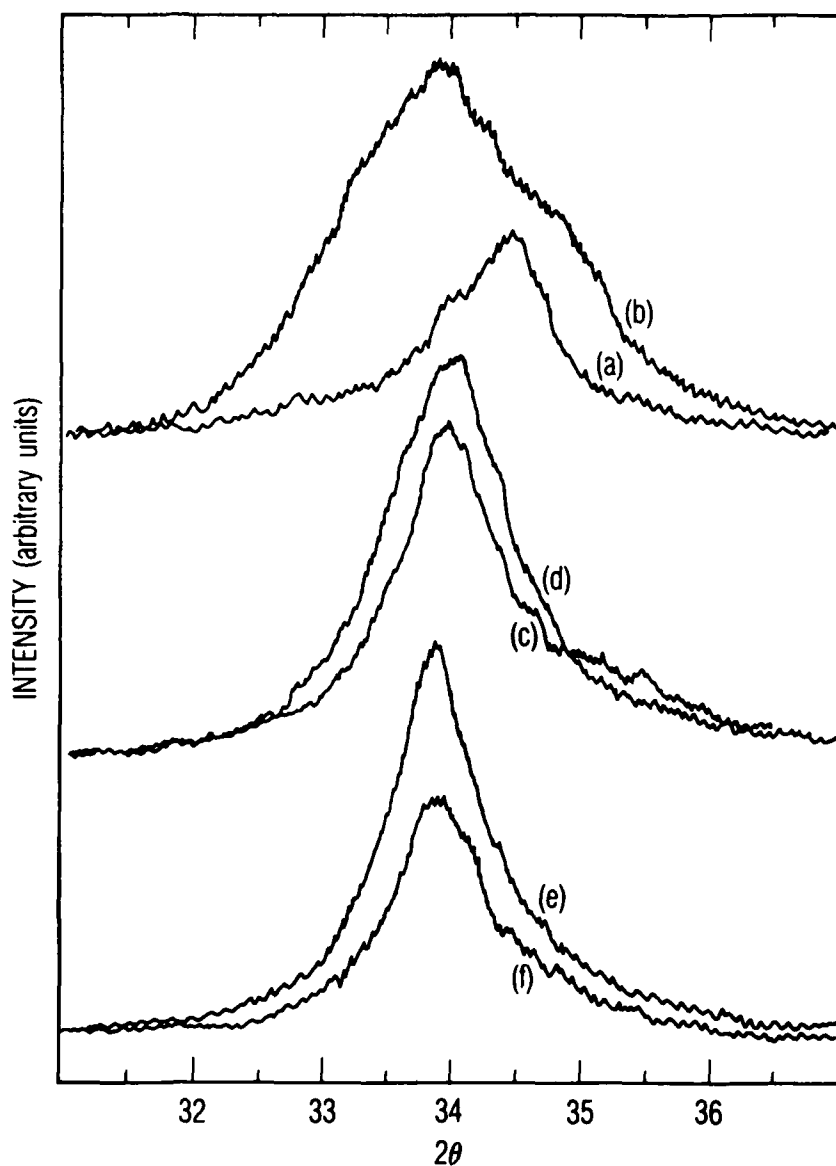


Fig. 8. XRD scans of the (100) peak for sputter-deposited MoS_2 films: (a) impure, (b) impure annealed, (c) pure, (d) pure annealed, (e) pure, and (f) pure oxidized by 10 months' storage at 85% RH.

Figure 8 indicates that at least two different species with the MoS_2 crystal structure can be formed during sputter deposition. The species with (100) d -spacing of 0.261 nm (curve a) was prepared prior to thorough outgassing of the sputtering chamber and target. XPS analysis reveals the presence of Mo(VI), and Auger depth profile analysis indicates elevated oxygen concentrations throughout the film. Annealing converts major portions of these films into a species whose d -spacing (0.265 nm) is closer to that of crystalline molybdenite (natural MoS_2 , $d = 0.273$ nm). Species with almost identical d -spacing (0.265 nm) were prepared when the sputtering chamber was thoroughly outgassed (curve c), and these purer species were not affected significantly by 500°C annealing. Finally, intentional oxidation of the pure material (curve f) reduced the amount of crystalline MoS_2 but did not convert it into the impure crystalline material.

Crystalline MoS_x of variable stoichiometry and purity can be formed during sputter deposition.^{32,38} Such materials appear to maintain the 2H crystal structure but with varying degrees of strain in the lattice. The purest material that we have made has an approximate 3.6% compression along the $\langle 100 \rangle$ direction. Although not detectable for as-prepared films, rubbed (worn) films, whose orientation changes with rubbing, show a comparable expansion in the $\langle 001 \rangle$ direction. Films with a slight excess in S, over the stoichiometric amount, provide better overall lubrication, represented by lower friction and longer wear life.^{23,38}

We propose that changes in lattice spacing within the MoS_x crystallites are due to variations in electron density around the Mo atom and specifically to changes in the population of the nonbonding A_1' (primarily Mo d_{z^2}) orbital. Oxygen substitution for sulfur within MoS_2 crystallites removes electron density from this orbital that is spatially directed between S atoms above and below the Mo in the trigonal prism (see Fig. 2). Removal of electron density from this orbital does not change bond order (the electrons are nonbonding), and therefore bond length, but does reduce repulsion between d_{z^2} electrons and S electrons. This reduced repulsion permits S-S in-plane distances to be reduced, which allows for compression

along directions perpendicular to edge planes and expansion in the basal direction. Such oxygen substitution must occur throughout the interior of the individual crystallites, as happens during deposition in the contaminated sputtering chamber. (The crystallites have a high defect concentration.) Postdeposition oxidation, during storage in a humid atmosphere at room temperature, apparently creates layers of amorphous oxide on the edge surfaces of the crystals that have no effect on the internal electron densities and thus on the lattice spacings of the remaining MoS_2 . Annealing of the impure material in vacuum or an inert atmosphere can cause two changes: sublimation of oxidized (MoO_3) material, and crystallization of amorphous MoS_2 .

In contrast to oxidized sputtered films, the opposite changes in lattice spacings were observed³⁹ for alkali metal intercalation of NbSe_2 . Niobium, having one less d electron than molybdenum, can be readily intercalated with alkali atoms that ionize by donating an electron to the half-filled Nb d_{z^2} orbital. Extended x-ray absorption fine structure (EXAFS) measurements have shown that the intercalated material is expanded in the edge directions and contracted in the basal direction with no change in Nb-Se bond length.

Expansion of the trigonal prismatic lattice in the basal direction has been associated with reduced friction for various materials.² On the basis of the XRD measurements reported here, and with the aid of the MO interpretation, we predict that substitution within the MoS_2 lattice, during preparation, of electron acceptor-type dopants (of which oxygen is a special case) will reduce the friction below that of the parent pure material. There is evidence that slight oxidation of sputter-deposited MoS_2 lowers its friction coefficient,³² and films with slightly elevated S:Mo (greater than 2) ratios have measurably lower friction coefficients than stoichiometric or sulfur-deficient films.³⁸ Another system predicted to have improved lubrication properties is MoS_2 films that have a small percentage of Nb substituted for the Mo.

The ideal lubricant film should be one that adheres well to the substrate material and that has the lowest possible friction. Substitution of some sulfur by another species within the interface region has already been mentioned for improving adhesion. Arsenic might be an appropriate substituent, since it would be an acceptor for some metal electron density; but the precise property that makes it good for adhesion at the interface, its ability to hybridize using d orbitals, would probably encourage interlayer bonding and thus increase friction within the bulk of the film. Instead, an appropriate substituent within the bulk film for reducing friction would be phosphorus, an acceptor that does not have d orbitals available for hybridization and bonding. The preparative task for achieving the best possible lubricant material will be to control interface and bulk compositions independently. The value of studying the electronic structure of solid lubricant materials and using this information to design new or modified lubricants cannot be overstated.

V. SUMMARY AND CONCLUSIONS

A qualitative molecular orbital model, based on D_{3h} symmetry and periodic repetition of the Mo(S)_6 unit within the MoS_2 crystal, agrees well with the results of spectroscopic measurements of valence-level transitions and can be used to interpret crystallographic variations in MoS_2 thin films. This model involves a total of seven valence-level molecular orbitals, six of which form the bonds between the central Mo and the six S atoms and one of which is considered to be nonbonding. Such an interpretation contradicts the model based on augmented-spherical-wave calculations, wherein the uppermost state was assigned as an antibonding (d_{z^2}) state with support derived from photochemical studies.¹³ Our assignment of the highest filled level as a nonbonding level appears to be more physically realistic, because it results in a net bond order around the central Mo of six, a situation that is not realized with the alternative assignment. Our assignment provides explanations of spectroscopic and crystallographic data and can be used to predict substitution chemistry for improving lubrication properties.

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LABORATORY OPERATIONS

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